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| SERIAL NUMBER 10/730,465 | FILING OR 371(c) DATE 12/08/2003 RULE | CLASS 134 | GROUP ART UNIT 1746 | ATTORNEY DOCKET NO. P/1596-71 | |
| APPLICANTS Hiroyuki Araki, Kyoto, JAPAN; Ryotaro Ogushi, Kyoto, JAPAN; Shuzo Nagami, Kyoto, JAPAN; <i>M.K. (NONE)</i> | | | | | |
| ** CONTINUING DATA ***** <i>M.K. (verified)</i> | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2002-359357 12/11/2002 | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/09/2004 | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>[Signature]</i> <i>M.K.</i> Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 4 | TOTAL CLAIMS 16 | INDEPENDENT CLAIMS 2 |
| ADDRESS 000002352 | | | | | |
| TITLE Substrate treating apparatus and substrate treating method | | | | | |
| FILING FEE RECEIVED 770 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |